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# Difluorinated 6,13-Bis(triisopropylsilylethynyl)pentacene: Synthesis, Crystallinity, and Charge-Transport Properties

Chang-Hyun Kim,<sup>\*,[a, d]</sup> Htay Hlaing,<sup>[b]</sup> Marcia M. Payne,<sup>[c]</sup> Sean R. Parkin,<sup>[c]</sup> John E. Anthony,<sup>[c]</sup> and Ioannis Kymissis<sup>\*,[b]</sup>

Fluorination has been demonstrated to improve stability and processing in thiophene-containing small-molecule semiconductors. Here, the impact of partial fluorination on these parameters in a pentacene derivative is examined. Although the improvement in photostability is not as dramatic, there is

a clear improvement in the stability of the chromophore upon fluorination. The improvement in processability is more dramatic; devices formed by spin-coating with the fluorinated derivative perform substantially better than those formed from the nonfluorinated compound.

## 1. Introduction

Organic semiconductors offer a fascinating platform for studying the impact of small changes in molecular functionalization on properties as diverse as crystallization rate, photo-stability, crystal packing, and charge-transport properties. In anthradithiophene-based chromophores, for example, it has been shown that the addition of just two fluorine substituents both dramatically enhanced the stability of the semiconductor<sup>[1]</sup> and enhanced crystallization rates to allow formation of crystalline films with good semiconductor performance using techniques such as spin-coating.<sup>[2]</sup> We were curious whether this partial-fluorination strategy provided a general benefit to other acene-like chromophores; enhancement of stability of anthradithiophenes by fluorination likely arises from chemical “blocking” of the most-reactive thiophene positions (Figure 1). In chromophores without terminal thiophene moieties, such blocking would not be operative. Furthermore, simple difluorination would likely yield a mixture of isomers, which might further complicate crystallization.

In this study, we report on the material and device properties of a difluorinated 6,13-bis(triisopropylsilylethynyl)pen-

tacene (diF-TIPS-Pn; Figure 1). This new organic semiconductor has excellent solubility and crystallizes rapidly, enabling the spin-casting deposition of an active channel layer for organic field-effect transistors (OFETs). We investigated the characteristic crystal growth upon solvent drying by means of polarized optical microscopy, and the nanostructure of the semiconductor thin films were analyzed using grazing-incidence wide-angle X-ray scattering (GIWAXS) measurements. OFETs are used as a platform for understanding the electrical transport properties of the gate-controlled charge carriers in diF-TIPS-Pn. Upon presenting the data from a device based on this material, we address the limitation of the simplified parameter extraction model, and provide a comparison of several advanced approaches.

## 2. Results and Discussion

### 2.1. Synthesis and Material Characteristics

The difluorinated acene was easily synthesized using standard chemistry protocols. Starting from the commercially available 4-fluoro-*o*-xylene, bromination followed by Cava reaction yielded the intermediate pentacene quinone (Scheme 1). Ethynylation followed by deoxygenation provided diF-TIPS-Pn in good yield.

The photostability of the fluorinated pentacene was studied in 0.5 wt% solutions in toluene, and compared with similar solutions of the nonfluorinated TIPS-Pn. Absorption spectra of the solutions were measured every 2 h until the solution half-life could be obtained (Figure 2). For TIPS-Pn, a half-life of approximately 4 h was extracted from this study, whereas diF-TIPS-Pn exhibited a half-life of >6 h under identical conditions. Although the 50% improvement in half-life is not as dramatic as that seen for the corresponding anthradithiophenes, it demonstrates that partial fluorination does improve solution stability, likely by hindering oxidative decomposition pathways.

[a] Dr. C.-H. Kim  
LPICM, Ecole Polytechnique, CNRS  
91128 Palaiseau (France)  
E-mail: chang-hyun.kim@polytechnique.edu

[b] Dr. H. Hlaing, Prof. I. Kymissis  
Department of Electrical Engineering  
Columbia University  
New York, NY 10027 (USA)  
E-mail: johnkym@ee.columbia.edu

[c] Dr. M. M. Payne, Dr. S. R. Parkin, Prof. J. E. Anthony  
Department of Chemistry  
University of Kentucky  
Lexington, KY 40506 (USA)

[d] Dr. C.-H. Kim  
Current address:  
School of Materials Science and Engineering  
Gwangju Institute of Science and Technology  
Gwangju 500-712 (Republic of Korea)

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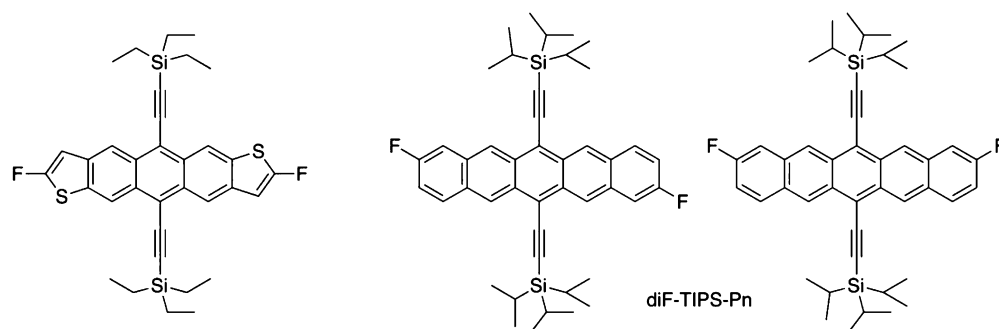
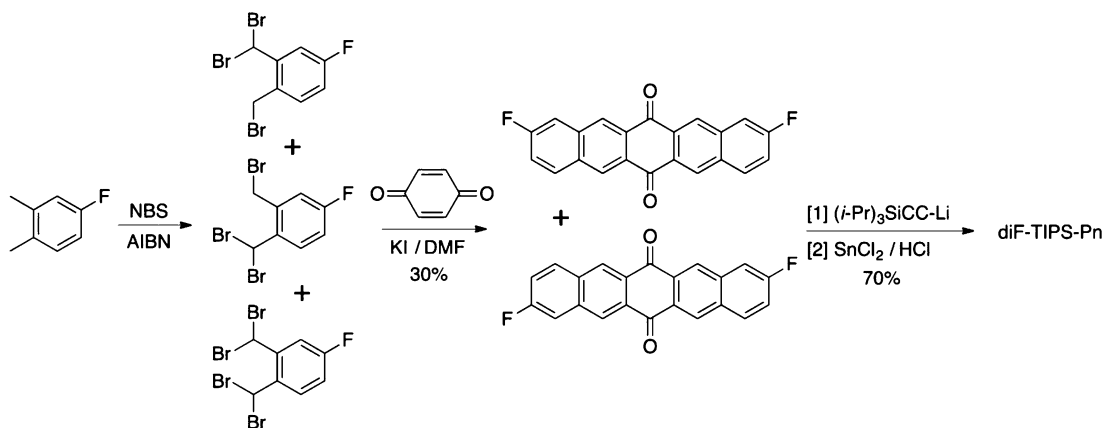


Figure 1. Fluorinated anthradithiophene (left), and the mixture of diF-TIPS-Pn isomers.



Scheme 1. Synthesis of diF-TIPS-Pn.

X-ray crystallographic analysis of diF-TIPS-Pn was performed, demonstrating that the material adopts a 2D “brickwork” crystal packing nearly identical to that determined for TIPS Pn,<sup>[3]</sup> as shown in Figure 3. It is obvious that the fluorine atoms are scrambled over all possible positions in the solid state—a function of the fact that a fluorine substituent is similar in size to a hydrogen atom. More importantly, it is clear that fluorination had no impact on the crystal packing—the overall arrangements for TIPS-Pn and diF-TIPS-Pn are essentially identical, with no changes in molecular orientation or carbon–carbon contacts; even the disorder of the single isopropyl group on each silane is nearly identical for the two compounds.

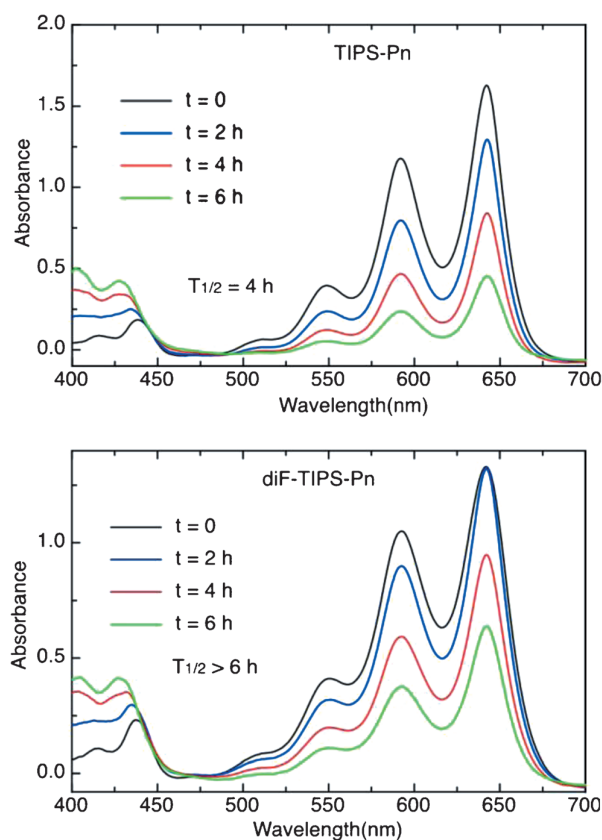
## 2.2. Contact-Induced Crystal Growth

Organic crystals are formed by weak van der Waals forces. This underlines the significant impact the substrate chemistry has on the arrangement of deposited molecules, because substantial substrate–molecule interactions can be comparable to, or even dominant over, intermolecular forces.<sup>[4,5]</sup> As efficient charge transport necessitates a high degree of solid-state order and ideal orientation of the crystallites,<sup>[6,7]</sup> understanding and exploiting the surface properties for obtaining a desired film structure is of great importance.

In complete OFET devices, a semiconductor layer sits on the  $\text{SiO}_2$  channel region and on the chemically functionalized Au

source/drain electrodes as illustrated in Figure 4a. Figure 4b shows that the morphology is significantly different on these two characteristic surfaces. Pentafluorobenzenethiol (PFBT) is a widely used self-assembled monolayer (SAM) material for charge-injection contacts.<sup>[8–11]</sup> Previously, extensive studies were conducted on difluorinated 5,11-bis(triethylsilylethynyl)-anthradithiophene films grown on PFBT-treated Au. They suggested that fluorine–fluorine and sulfur–fluorine interactions between the semiconductor and the electrode promote molecular packing, as evidenced by the alignment of crystalline domains along the electrode edges.<sup>[8,12–14]</sup> In our diF-TIPS-Pn devices, similar phenomena were observed (Figure 4b), by which nucleation is predominantly initiated on the electrode regions with the growth extending laterally to fill the channel. A noticeable optical contrast inversion upon rotation of the sample (Figure 4c) characterized the highly ordered crystalline domains.<sup>[15,16]</sup>

From the images in Figure 4b,c, it can be inferred that the width and length of the grains in the channel are restricted by the nucleation density on the electrodes and the channel length ( $L$ ), respectively. Moving farther away from an electrode, more spatially distributed nucleation on  $\text{SiO}_2$  were observed, which eventually creates zones with large spherulitic domains (Figure 4d).<sup>[17]</sup> This image reveals the exceptional ability of diF-TIPS-Pn to strongly correlate and form crystalline domains under solution casting. However, we cannot simply expect that



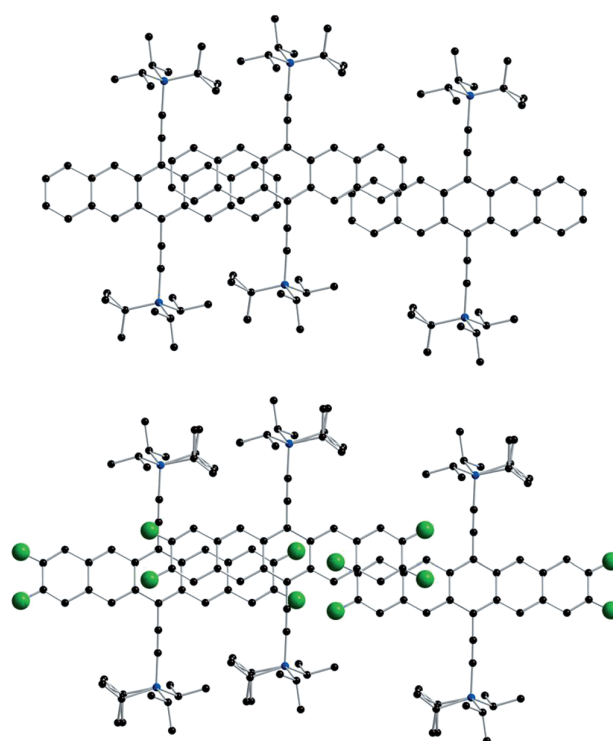
**Figure 2.** Decomposition of TIPS-Pn (top) and diF-TIPS-Pn (bottom) in solution, monitored by absorption spectroscopy.

long-range (channel-scale) charge transport would be superior within this region; the arbitrary orientation of domains results in a number of high-angle grain boundaries that render inter-grain current flow inefficient.<sup>[18]</sup> Although smaller, the contact-grown grains in Figure 4b,c are “in-plane” directional. In practice, charge carriers encounter only one “mid-channel” boundary, and even this boundary is low-angled and thus easy to pass through.<sup>[18]</sup>

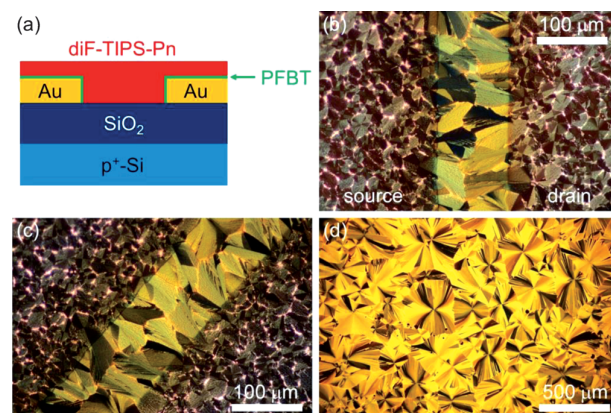
### 2.3. GIWAXS

2D GIWAXS is a powerful method to quantitatively determine the nanoscale crystalline structures and substrate-relative domain orientations, and its application to organic electronic materials has recently received growing attention.<sup>[19–24]</sup>

In order to investigate the crystallinity of the diF-TIPS-Pn films on morphologically distinguishable PFBT–Au and SiO<sub>2</sub> regions, GIWAXS measurements were separately conducted on these two locations. The 2D scattering patterns (Figure 5a,b) feature strikingly well-defined peaks including many high-order peaks, characteristic of a well-defined molecular crystal structure. A spin-cast organic film tends to poorly crystallize due to fast drying of the solvent.<sup>[25]</sup> Therefore, we estimate that diF-TIPS-Pn molecules have an outstanding ability to crystallize, and the fluorinated arenethiol layer coating the Au sur-



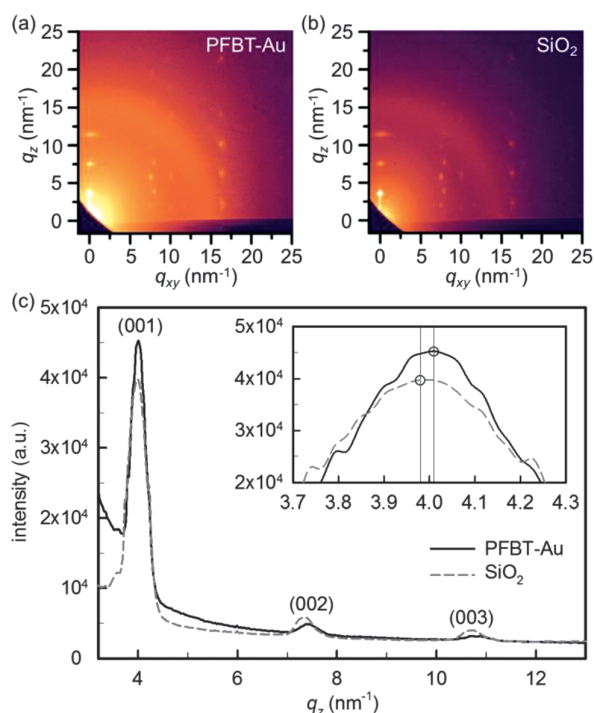
**Figure 3.** A comparison of the crystal packing of TIPS-Pn (top) and diF-TIPS-Pn (bottom).



**Figure 4.** a) OFET device architecture and materials. b) Optical image under crossed polarizers showing the morphology of a spin-cast diF-TIPS-Pn film. c) Image of the same region as (b) with the sample rotated with respect to the fixed polarizing angles. d) Polarized optical image at lower magnification on a far-electrode SiO<sub>2</sub> region.

face plays an additional role in generating a highly crystalline semiconducting thin film.

The scattering peaks do not show substantial angular spreading, indicating that there is a well-defined preferential orientation of the crystallites with respect to the substrate. The position of the peaks corresponds to the so-called “edge-on” motif, as evidenced by the pronounced (00 *l*) peaks along the *q*<sub>z</sub> axis.<sup>[26]</sup> It is important to note that efficient lateral conduction for OFETs is achieved with these edge-on crystals due to

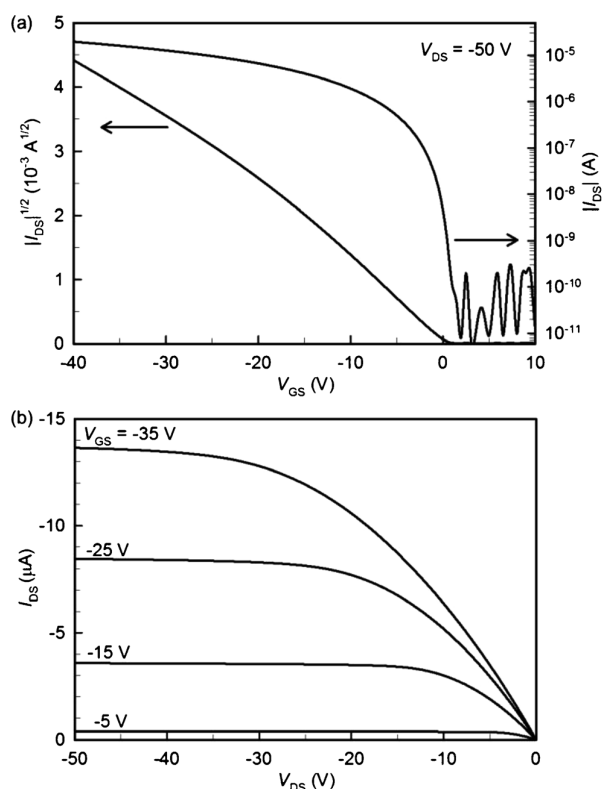


**Figure 5.** 2D GIWAXS images of the spin-cast diF-TIPS-Pn film on a) PFBT-Au and b) SiO<sub>2</sub>. c) The out-of-plane profiles at  $q_{xy}=0$ ; inset: magnification of the (001) peaks; the maximum data points of the two profiles are marked by circles.

the significant  $\pi$ - $\pi$  overlap aligned in the transport direction. Figure 5c shows a comparison of the extraction of the out-of-plane scattering profile of the two substrates. Although the peak distribution looks overall similar on PFBT-Au and SiO<sub>2</sub>, the exact  $q_z$  values resulting in the series of (001) peaks were slightly smaller for SiO<sub>2</sub>. The extracted  $q_{001}$  value is 4.01 nm<sup>-1</sup> for the crystals on PFBT-Au and 3.98 nm<sup>-1</sup> for those on SiO<sub>2</sub> (Figure 5c). The corresponding interlayer spacing  $d_{001}=2\pi/q_{001}$  is 1.56 nm for PFBT-Au and 1.57 nm for SiO<sub>2</sub>. Although not significant, this difference can arise from the stronger attraction of the PFBT-Au surface for the diF-TIPS-Pn molecules upon crystallization, eventually creating more condensed regions.

#### 2.4. OFET Analysis

The charge-transport properties of diF-TIPS-Pn were studied by measuring current-voltage ( $I$ - $V$ ) characteristics of the spin-cast OFETs. As the on-state current flow is attributed to the controllable (i.e. quantifiable) gate-induced charge carriers, OFETs provide practical access to the charge-carrier mobility ( $\mu$ ) from  $I$ - $V$  characteristics.<sup>[27]</sup> The  $I$ - $V$  data from a representative diF-TIPS-Pn transistor are shown in Figure 6. The channel width ( $W$ ) and  $L$  of this transistor are 3000 and 100  $\mu\text{m}$ , respectively. The transfer characteristic (Figure 6a) shows a large modulation of drain current ( $I_{DS}$ ) by the gate voltage ( $V_{GS}$ ) by a factor of the order of  $10^5$ , a property necessary for low-leakage switching applications. The on state observed at negative  $V_{GS}$  values indicates the  $p$ -type field-effect behavior achieved by holes inject-



**Figure 6.** a) Saturation-regime transfer characteristic of a diF-TIPS-Pn transistor on a semi-log scale and the square root of the same data on a linear scale. b) Output characteristics of the same device. This OFET has  $W=3000$   $\mu\text{m}$  and  $L=100$   $\mu\text{m}$ .

ed from the Au electrodes. The output curves [ $I_{DS}$  vs. drain voltage ( $V_{DS}$ ); Figure 6b] feature an almost ideal linear-to-saturation transition, suitable for applications such as organic light-emitting diode (OLED) driving circuits.<sup>[28]</sup>

Related to the virtually unlimited range of semiconductor materials and device structures, there is still no universal description for the device operation of OFETs. Likely due to its simplicity in implementation, the major choice of the research community has been to adopt the quadratic MOSFET  $I$ - $V$  model based on the gradual channel approximation.<sup>[27,29,30]</sup> However, it is worth questioning the wide applicability of this model to OFETs for the following reasons. Structural and energetic disorder is characteristic of organic semiconductors, which dictates a strong dependence of  $\mu$  on the applied  $V_{GS}$ .<sup>[31-33]</sup> Also, the ideal MOSFET model does not include contact resistance ( $R_c$ ), which generally exists due to a substantial charge-injection barrier at direct metal-semiconductor junctions in OFETs.<sup>[34-36]</sup> From a behavioral point of view, both aspects ( $V_{GS}$ -dependent  $\mu$  and the  $R_c$  effect) manifest themselves by a deviation of a measured saturation-regime  $|I_{DS}|^{1/2}$  versus  $V_{GS}$  curve from a perfectly straight line.<sup>[37-40]</sup> Our OFET also exhibits such a trend (Figure 6a), and therefore estimating a unique slope for the single  $\mu$  value is not possible. Herein-after, we suggest alternative ways to extract  $\mu$  values that allow the utilization of the entire range of transfer curves with a more physically based description. We will summarize the as-



sumptions behind each model, and explain their implementation and relative advantages and drawbacks.

The first method is based on the second derivative of the transfer curves. Essentially, the same form of the saturation-regime MOSFET equation is used with an additional freedom in the variation of  $\mu$  with  $V_{GS}$ . We define  $\mu_{SD}$  as the mobility extracted by the second derivative and write Equation (1) for the  $p$ -type operation:

$$I_{DS} = -\frac{W}{2L}\mu_{SD}C_i(V_{GS} - V_T)^2 \quad (1)$$

where  $C_i$  is the gate insulator capacitance per unit area and  $V_T$  is the threshold voltage. Although not often explicitly mentioned,<sup>[10,41]</sup> the derivations lead to a simple equation only by assuming a weak  $V_{GS}$ -dependence, which ignores the  $d\mu_{SD}/dV_{GS}$  and  $d^2\mu_{SD}/dV_{GS}^2$  terms. Therefore, Equation (2) should be considered as an approximation:

$$\frac{d^2I_{DS}}{dV_{GS}^2} \approx -\frac{W}{L}\mu_{SD}C_i \quad (2)$$

rearrangement of which for  $\mu_{SD}$  gives Equation (3):

$$\mu_{SD} \approx \frac{d^2I_{DS}}{dV_{GS}^2} \times -\frac{L}{W} \times \frac{1}{C_i} \quad (3)$$

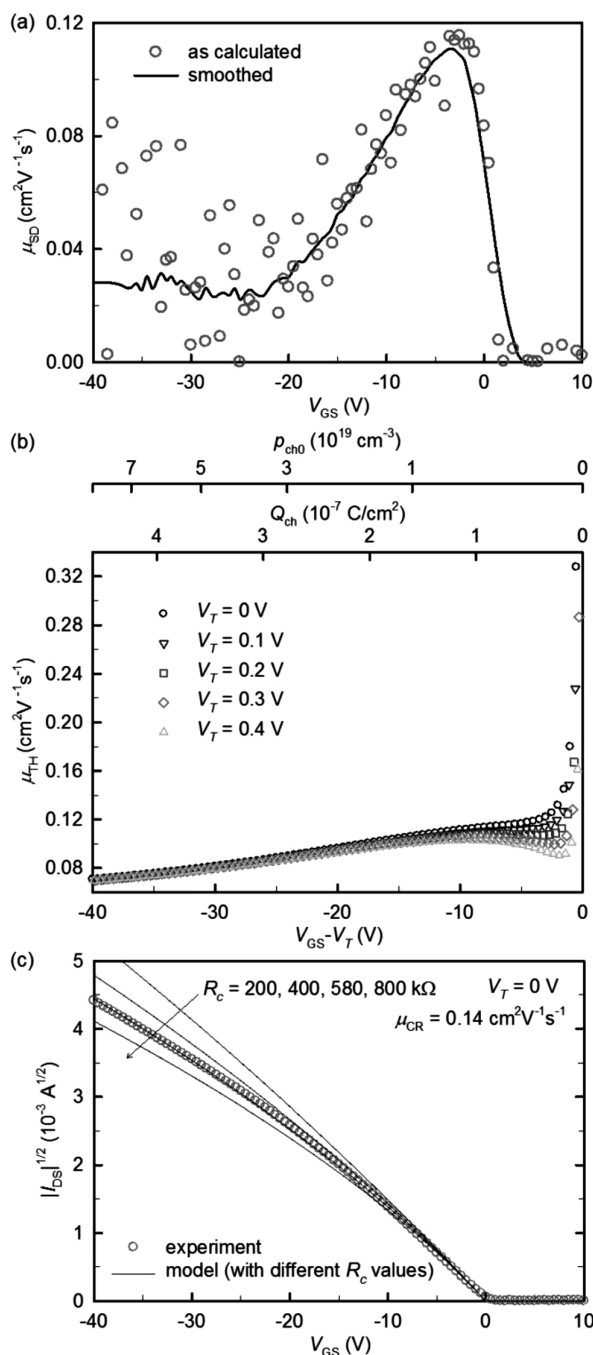
A major advantage of this method is to estimate the  $V_{GS}$  dependence of  $\mu$  without simultaneous estimation of  $V_T$ . Similarly to  $\mu$ , the  $V_T$  can be extracted by various methods that produce potentially different values.<sup>[42,43]</sup> Therefore, the elimination of  $V_T$  by two derivations from Equation (1) allows one to be freed from the additional complications of the choice of method and voltage range for  $V_T$  extraction. However, the method tends to amplify the measurement noise because mathematical derivations are involved (Figure 7a). As superposed here, a data-smoothing algorithm can be applied when, for instance, the functional form of  $\mu$  versus  $V_{GS}$  is to be precisely modeled.

The second method relies upon a predetermined  $V_T$  value, so we term  $\mu_{TH}$  (TH=threshold) as the mobility extracted this way. We replace  $\mu_{SD}$  by  $\mu_{TH}$  in Equation (1). The difference consists in the direct arrangement for  $\mu_{TH}$ , leading to Equation (4):

$$\mu_{TH} = I_{DS} \times -\frac{2L}{W} \times \frac{1}{C_i} \times \frac{1}{(V_{GS} - V_T)^2} \quad (4)$$

Equation (4) clearly shows that the value of  $V_T$  should be first determined to calculate the value of  $\mu_{TH}$  at each  $V_{GS}$  from a measured saturation-regime transfer curve. As shown in Figure 7b, noise-free estimation of the  $V_{GS}$ -dependent mobility is possible. Furthermore, additional physical correlation can be introduced because the accumulated channel charge density is proportional to the gate overdrive voltage  $V_{GS} - V_T$  [Eq. (5)]:

$$Q_{ch} = -C_i(V_{GS} - V_T) \quad (5)$$



**Figure 7.** Calculation and visualization for the different parameter extraction schemes applied to the transfer curve shown in Figure 6a. a) Second-derivative method, b) threshold-voltage method, and c) contact-resistance method.

where  $Q_{ch}$  is the capacitively induced hole charge density per unit area in the organic channel. By assuming a Mott–Gurney-type charge distribution (for a semi-infinite metal–insulator junction), the interfacial channel hole density per volume  $\rho_{ch0}$  can be calculated [Eq. (6)]:<sup>[36]</sup>

$$\rho_{ch0} = \frac{Q_{ch}^2}{2\epsilon_s kT} = \frac{C_i^2 (V_{GS} - V_T)^2}{2\epsilon_s kT} \quad (6)$$

where  $\epsilon_s$  is the semiconductor permittivity,  $k$  is the Boltzmann constant, and  $T$  is the absolute temperature. The calculated  $\mu_{\text{TH}}$  of our diF-TIPS-Pn transistor as a function of  $V_{\text{GS}}-V_{\text{p}}$ ,  $Q_{\text{chv}}$ , and  $\rho_{\text{ch0}}$  is shown in Figure 7b. We used  $\epsilon_s=3.5\times\epsilon_0^{[44]}$  and  $T=300\text{ K}$  ( $\epsilon_0$  is the vacuum permittivity). As the last term in Equation (4) goes to infinity as  $V_{\text{GS}}\rightarrow V_{\text{p}}$ , the result is highly sensitive to the value of  $V_{\text{T}}$  especially near  $V_{\text{GS}}-V_{\text{T}}=0\text{ V}$ . We also note that the locally high values at the first one or two data points nearest to  $V_{\text{GS}}-V_{\text{T}}=0\text{ V}$  are due to the same specificity of the calculation.

The third method includes  $R_{\text{c}}$  in the  $I$ - $V$  model, and the corresponding mobility is termed  $\mu_{\text{CR}}$  (CR = contact resistance). As proposed by Natali and co-workers,<sup>[45]</sup> a contact voltage drop at the source electrode accounts for the reduction in current, and the self-consistent saturation-regime drain current  $I_{\text{CR}}$  can be written as Equation (7):

$$I_{\text{CR}} = \frac{V_{\text{GS}} - V_{\text{T}}}{R_{\text{c}}} + \frac{L}{W\mu_{\text{CR}}C_{\text{i}}R_{\text{c}}^2} \left[ -1 + \sqrt{1 - \frac{2W}{L}\mu_{\text{CR}}C_{\text{i}}R_{\text{c}}(V_{\text{GS}} - V_{\text{T}})} \right] \quad (7)$$

Due to the interdependency between  $\mu_{\text{CR}}$  and  $R_{\text{c}}$ , the extraction of separate parameters at each  $V_{\text{GS}}$  cannot be achieved with a single device. In other words, either  $\mu_{\text{CR}}$  or  $R_{\text{c}}$  should have a known functional  $V_{\text{GS}}$  dependence to assign a functional freedom to the other and extract its unknown  $V_{\text{GS}}$  dependence. Nonetheless, a broad range within the transfer curve of our OFET can be sufficiently well fitted by using constant  $\mu_{\text{CR}}$  and  $R_{\text{c}}$  values ( $R_{\text{c}}=580\text{ k}\Omega$  curve in Figure 7c), which might serve as an approximation to their relatively weak  $V_{\text{GS}}$  dependence. The extracted  $\mu_{\text{CR}}$  value of  $0.14\text{ cm}^2\text{V}^{-1}\text{s}^{-1}$  averages the charge-transport property of the diF-TIPS-Pn channel unaffected by the contact-related current reduction, and this value is close to the  $\mu_{\text{SD}}$  or  $\mu_{\text{TH}}$  under low  $|V_{\text{GS}}|$ . Therefore, we observe an enhancement in OFET performance as compared to the reported  $\mu$  value of spin-cast TIPS-Pn transistors of  $<0.04\text{ cm}^2\text{V}^{-1}\text{s}^{-1}$ .<sup>[46]</sup> Considering negligible contribution of the fluorine atoms to the packing structure (Figure 3), the contact-induced self-assembly-promoting in-plane ordering of crystallites is expected to be the major factor in the improvement. Figure 7c also contains the calculated transfer curves according to Equation (7), with adjacent  $R_{\text{c}}$  values to visualize the pronounced bending with increasing  $R_{\text{c}}$ . Note that recent reports on high-mobility materials often showed a similar deviation, highlighting the inability of the injection contacts to provide sufficient charge carriers that can fully utilize the highly conductive channel.<sup>[38–40,47]</sup>

### 3. Conclusions

We have investigated a novel semiconductor, diF-TIPS-Pn, with a particular focus on its application to OFETs. The chemical tuning of the widely studied TIPS-Pn was inspired by the benchmark already set with anthradithiophene derivatives; we observed a generalized enhancement of the stability of the material by fluorination, even in the absence of thiophene

moieties in the core structure. The excellent solubility of diF-TIPS-Pn enabled impressive processability for device manufacturing, and OFETs fabricated using spin-casting provided a platform for monitoring the thin-film microstructure and the charge-transport properties. The polarized optical microscopy and X-ray-based structural analysis showed that fluorination on the semiconductor activates contact-induced crystal growth along SAM-functionalized Au surfaces, generating well-aligned crystallites optimized for in-plane electrical conduction. A rigorous analysis of the mobility extraction methods was provided, for highlighting the necessity of careful inspection of measured transfer curves that exhibit substantial nonideality. In the framework of charge-transport physics within a uniform medium,  $\mu_{\text{SD}}$ - or  $\mu_{\text{TH}}$ -based methods can be more reliable if upward bending (of a  $|I_{\text{DS}}|^{1/2}$  vs.  $V_{\text{GS}}$  curve) is pronounced, because of the compatibility with the hopping or trap-dominated transport models. Downward bending is generally observed for high-performance semiconductors, and this was also the case for our diF-TIPS-Pn transistor.  $R_{\text{c}}$  is regarded as the major reason for this deviation, and we showed that an assumption of constant  $R_{\text{c}}$  and  $\mu_{\text{CR}}$  can sufficiently well describe the overall transfer characteristic. Our results deliver a comprehensive understanding of a newly proposed organic semiconductor, from chemical synthesis to device analysis, and they make a strong case for a rational molecular design strategy.

## Experimental Section

### Device Fabrication

OFETs were fabricated according to the structure in Figure 4a. A heavily doped  $p$ -type Si wafer covered with 300 nm  $\text{SiO}_2$  was used as a substrate and a common gate-electrode/insulator platform. The substrate was subsequently cleaned with acetone, isopropanol, and distilled water. A Cr adhesion layer (5 nm) and Au source/drain electrodes (35 nm) were deposited by vacuum evaporation through a shadow mask. The sample was then immersed into a PFBT solution (10 mM in isopropanol) for 1 h, followed by rinsing with pure isopropanol and blow-drying with nitrogen. diF-TIPS-Pn powder was dissolved in 1,2,3,4-tetrahydronaphthalene ( $17\text{ mg mL}^{-1}$ ). The semiconductor solution was spin-cast at 1000 rpm for 30 s, and the fabrication was completed with an immediate annealing of the samples on a hot plate at  $100^\circ\text{C}$  for 30 min.

### Electrical Characterization

Current-voltage characteristics of the OFETs were recorded using a semiconductor characterization system (Keithley 4200) in the dark at room temperature.

### Optical Characterization

Optical microscopy images were acquired with a Nikon Eclipse E600FN system under crossed polarizers. A Canon Rebel T3i EOS 600D digital single-lens reflex camera was mounted onto the microscope and computer-controlled for high-quality imaging.

## GIWAXS Measurements

GIWAXS measurements were performed at the undulator-based X9 beam line at the National Synchrotron Light Source (NSLS), Brookhaven National Laboratory. The incident X-ray beam with photon energy of 14.0 keV (wavelength 0.08856 nm) was collimated using slits and focused onto the sample position using Kirkpatrick–Biaz mirrors, providing a beam size of 100  $\mu\text{m}$  horizontal width and 50  $\mu\text{m}$  vertical width. The samples were fixed to the sample stage located inside the vacuum chamber (pressure  $\approx 40$  Pa) and grazing incidence with respect to the incident X-ray was obtained by tilting the stage. 2D scattering images were collected using a fiber-coupled CCD area detector (Photonic Science, Mountfield, UK, pixel size 0.102 mm), positioned 217 mm from the center of the sample stage. Measurements were performed at a variety of incident angles; the results presented in the manuscript were taken at the incident angle of  $0.12^\circ$ . Data conversion to q-space was accomplished by calibration using silver behenate powder.

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**Keywords:** charge transport · crystal structure · organic field-effect transistors · pentacenes · semiconductors

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